



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al.

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: R. Kunemund

For : A Method To Repair Localized Amplitude  
Defects In A EUV Lithography Mask Blank

APPLICATION FOR CHANGE IN CORRESPONDENCE ADDRESS

Commissioner for Patents  
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Dear Sir:

Please change the Correspondence Address for the above-identified

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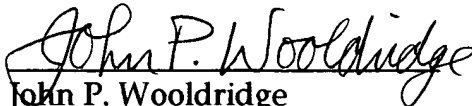
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If you have any questions, please contact the undersigned at 808-270-1011.

Respectfully submitted,

  
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Dated: April 27, 2004